



The R&D for ATLAS pixels for sLHC

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Outline



- The LHC upgrade
- The Pixel upgrade
- The IBL project
- The R&D for a new Inner Detector: the Planar Pixel Sensor Upgrade (PPSU) project
- Conclusions





LHC upgrade



The LHC in the high lumi area



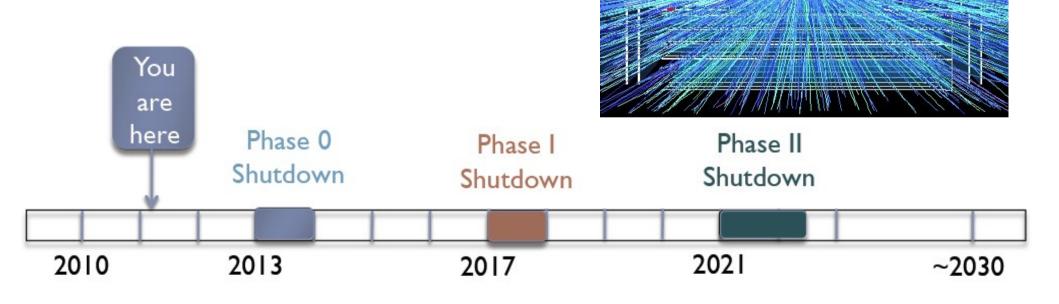
- The LHC is a discovery machine built to study
- → The ElectroWeak Symmetry Breaking mechanism
- The shortcomings of the Standard Model
- The discovery potential of the LHC can be enhanced by increasing its luminosity
- Infact, whatever is discovered, we'll want, at least, to
- Improve the measurement of its properties (masses, couplings, etc)
- → Test further predictions of the theories put forward to explain it



LHC Schedule



- Caveat: this schedule spans decades.
- Changes to the schedule could be prompted by
 - Physics landscape
 - Machine needs
 - Detector needs

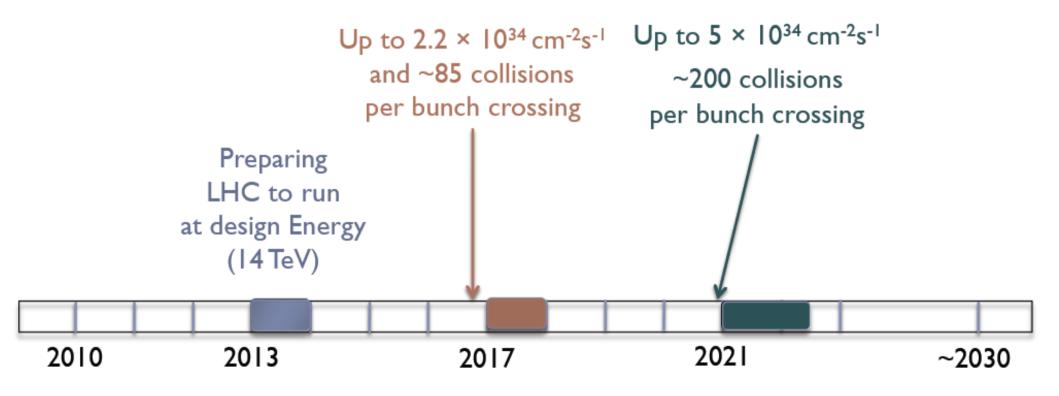




Luminosity plans



- Depends strongly on how the machine will be run
 - → Bunch spacing: 25 vs 50 ns?
 - → Leveling?
- → Estimates based on current planning

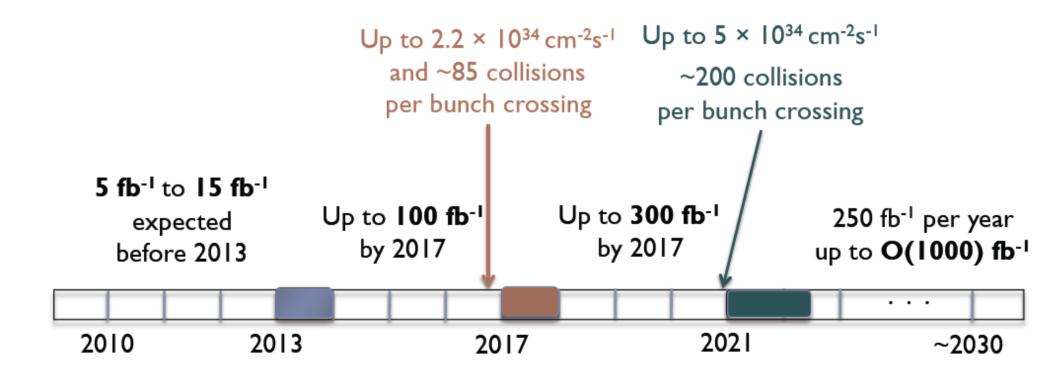




Luminosity plans



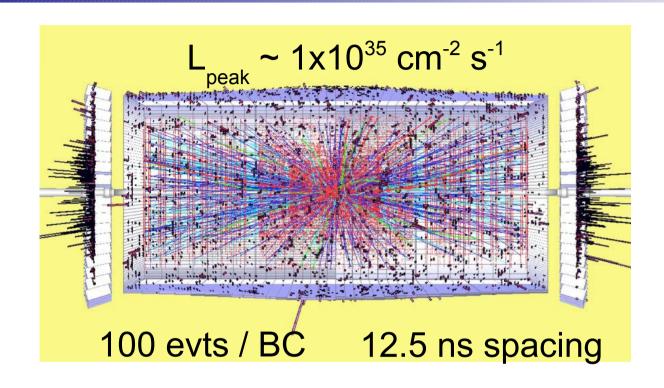
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High luminosity implications



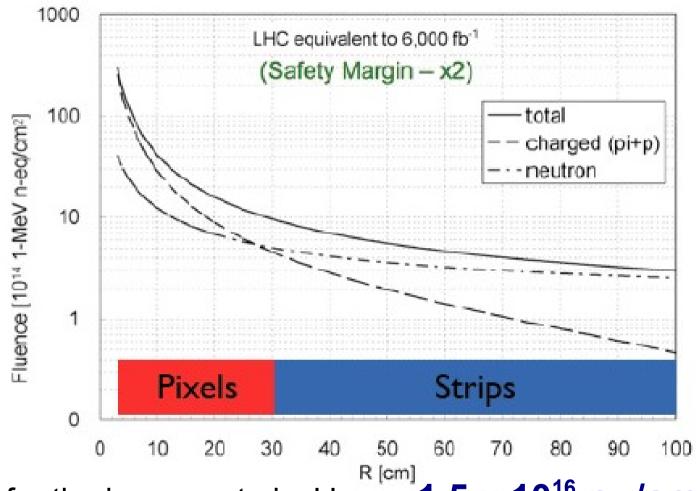


- More pile-up & higher rate events
- → Faster electronics
- → Higher granularity subdetectors



High luminosity implications





- fluences for the innermost pixel layer: 1.5 x 10¹⁶ n_{eq}/cm² (3 ab⁻¹)
- Radiation hard components



Macroscopic effects



Increase of leakage current

- can be helped with cooling

Change of the full depletion voltage V_{dep} (effective doping concentration N_{eff}).

every p-n-junction has a finite breakdown voltage

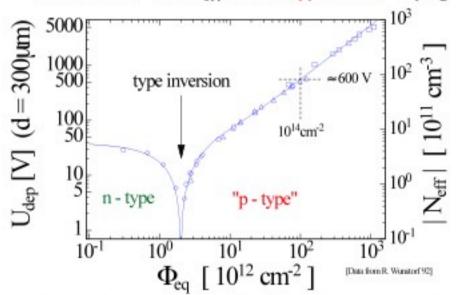
Decrease of the charge collection efficiency

- limited by partial depletion, trapping, type inversion

Change of the leakage current:

10⁻¹ n-type FZ - 7 to 25 KWm n-type FZ - 7 KWm n-type FZ - 4 KWm [A/cm³] □ n-type FZ - 3 KWtm p-type EPI - 2 and 4 KWm n-type FZ - 780 Wm 10^{-4} n-type FZ - 410 Wm n-type FZ - 130 Wm 10-5 n-type FZ - 110 Wm n-type CZ - 140 Wm p-type EPI - 380 Wm 10^{13} 10^{11} 10^{12} Φ eq [cm⁻²] [MMoll PhD Thosis]

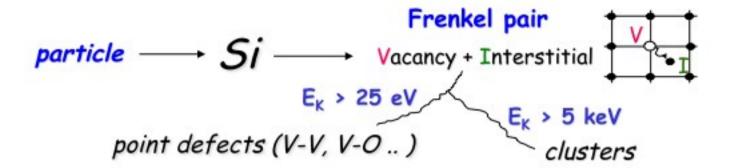
Evolution of the N_{eff} for n-type initial doping:



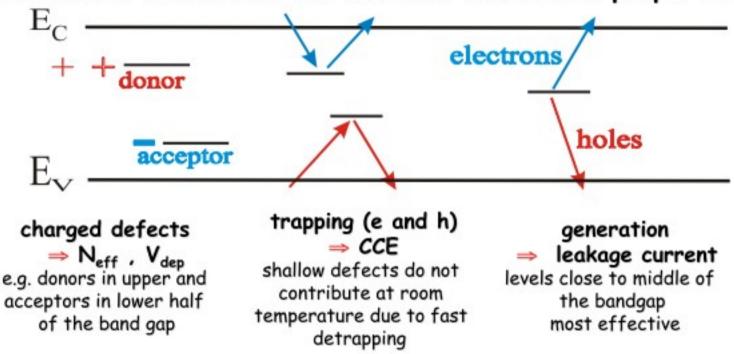
Panja Luukka, The Fifth International Forum on Advanced Material Science and Technology (IFAMST5 2006)



Radiation damage in silicon detectors



Influence of defects on the material and device properties



Panja Luukka, The Fifth International Forum on Advanced Material Science and Technology (IFAMST5 2006)

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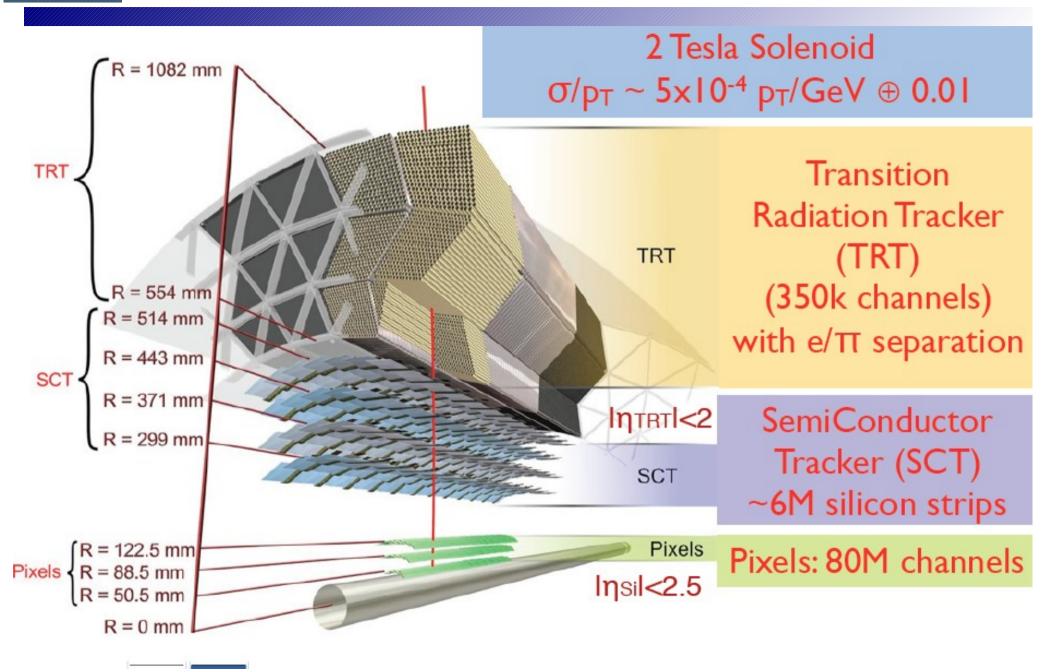


THE PIXEL UPGRADE



The current Inner Detector

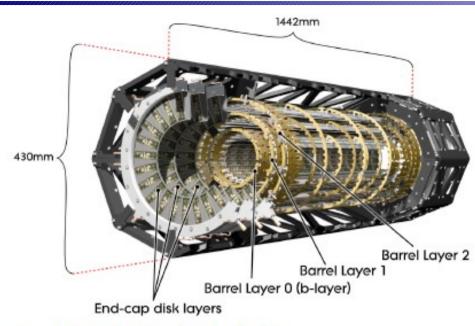






The current ATLAS Pixel detector



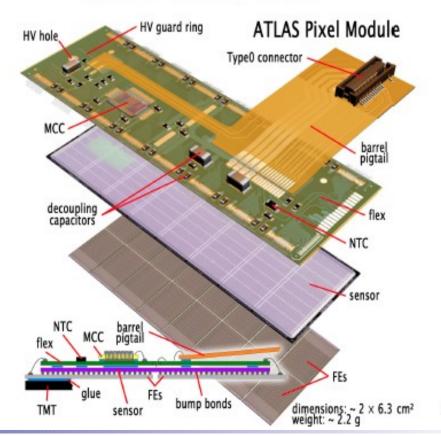


ATLAS Pixel Module

- 16 front-end chips (FE-I3) module with a Module Controller Chip (MCC)
- 46080 R/O channels 50 μm x 400 μm (50 μm x 600 μm for edge pixel columns between neighbour FE-I3 chips)
- Planar n-in-n DOFZ silicon sensors,
 250um tick
- Designed for 1 x 10¹⁵ 1MeV fluence and 50 Mrad
- Optolink R/O: 40÷80 Mb/link

ATLAS Pixel Detector

- 3 barrels + 3 forward/backwarc disks
- 112 stave and 4 sectors
- 1744 modules
- 80 million channels



IPRD10, Siena 9.6.2010 - Alessandro La Rosa (CERN)





THE INSERTABLE B-LAYER

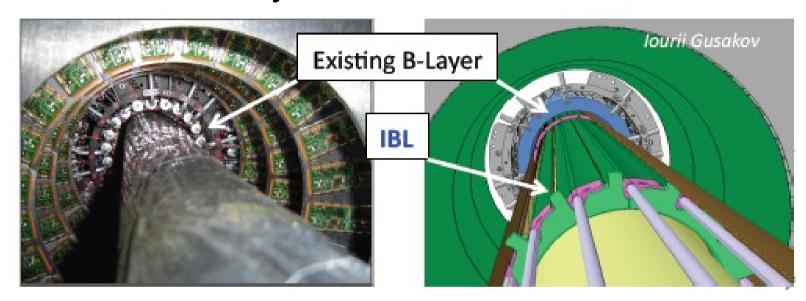


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A 4th pixel layer: Insertable B Layer



 Add a 4th low-mass Pixel layer inside the present B-layer: the Insertable B-Layer



3.2 cm from IP

- To improve performance of existing system
- To maintain performance of existing system when present
 B-layer starts degrading

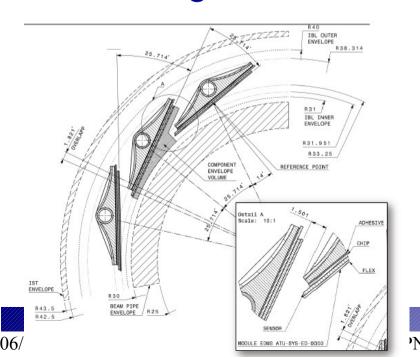
Scheduled for 2013

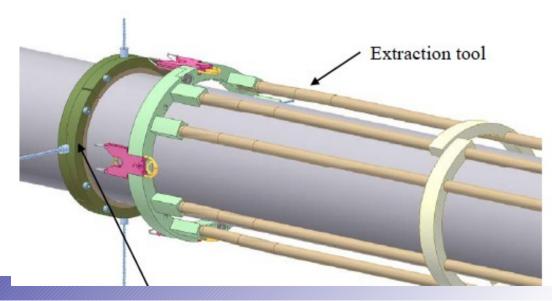


Why is IBL important



- This will be the first real upgrade project in the community
- Most of the problems and technologies necessary later for sLHC will be tested and solved already. Excellent test bench for later.
- → The IBL is the "technology" bridge to sLHC. Its specification required us to develop and use new technologies, which are directly relevant for sLHC

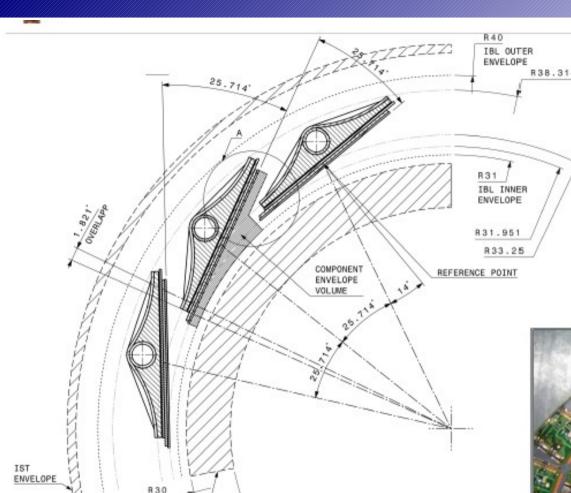






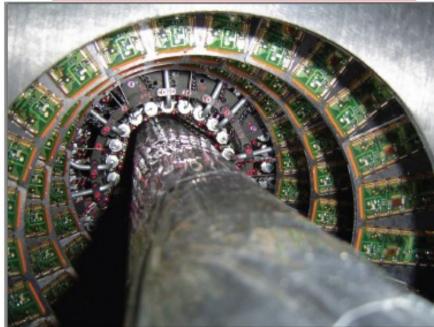
IBL - layout





- Beam-pipe reduction:
 - Inner R: 29 → 25 mm
- Very tight clearance:
 - "Hermetic" to straight tracks in Φ (1.8° overlap)
 - No overlap in Z: minimize gap between sensor active area.
 - Coverage in η (2σ-vertex spread): 2.6
- Material budget:
 - Stave, el.serv. Module: 1.16 % X₀
 - IBL Sup.Tube (IST): 0.28 % X₀

- Beam-pipe (BP) extracted by cutting the flange on one side and sliding (guiding tube inside).
- IBL Support Tube (IST) inserted.
- IBL with smaller BP inserted in the IST



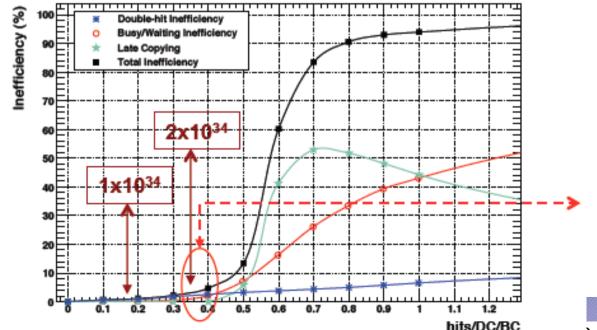


IBL - Luminosity effects



- The current Pixel R.O. designed for a peak luminosity of 1 x 10³⁴ cm⁻²s⁻¹.
- A luminosity at least twice that high is expected before the sLHC end
- Event pileup: redundancy in track measurement to control the fake rate
- High occupancy: induce readout inefficiencies
- Affects the B-layer more than other layers
- Would thereby limit the b tagging efficiency.
- IBL: low occupancy (with respect to SCT/TRT) reduces track fakes
- FE-I4 has higher bandwidth than existing readout.

FE-I3 inefficiency vs occupancy for B-layer



FE-I3 has 5% inefficiencies at the Blayer occupancy for 2.2x10³⁴. Steep rising function of occupancy: no safety margin.

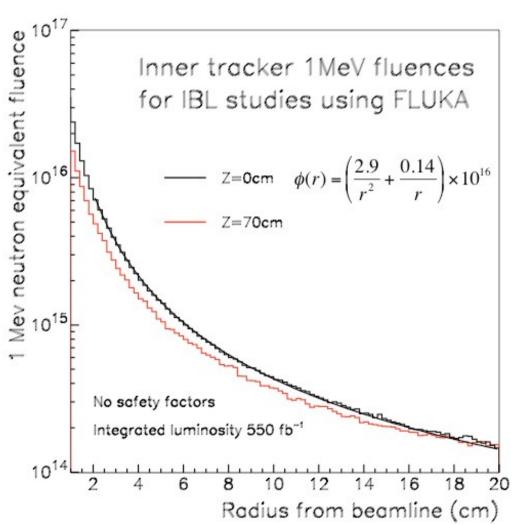


IBL – Radiation effects



IBL designed for 550 fb⁻¹ (provides margin should luminosity evolve more rapidly than expected or should 2020 HL-LHC shutdown be delayed)

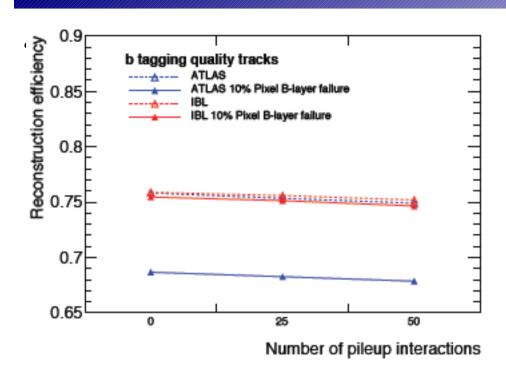
- NIEL dose @ 3.2 cm:
 3.3 x 10¹⁵ n_{eq}/cm²
- Safety factor: 5 x 10¹⁵ n_{eq}/cm²
 - TID: 250 Mrad



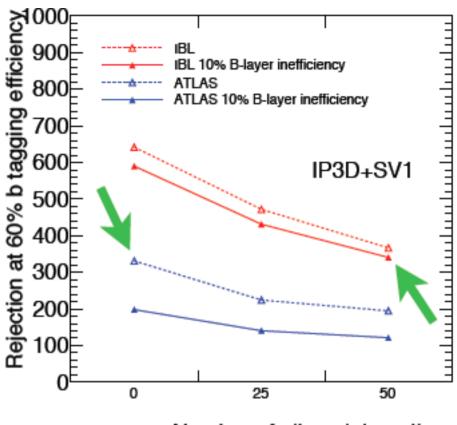


IBL performances





In a scenario with a 10% cluster inefficiency in the actual B-layer, the IBL recovers tracking efficiency and impact resolution



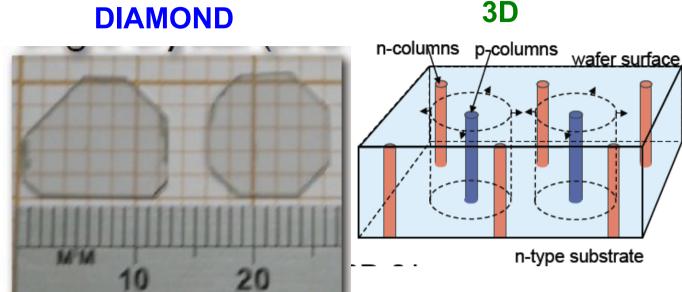
Number of pileup interactions

- Only minor effect on b-tagging performances
- Performing better than ATLAS w/o defects and pileup!



Sensor options for the IBL ...and sLH

 More details in the next slides



- Very low noise
- No cooling
- No doping needed
- Low capacitance
- Very high BD field
- Expensive
- Difficult to realize large sample of single crystal sensors

- Implants through the detector
- Highly segmented sensor
- Low depletion voltage
- Fast signal
- High rate capable
- Inefficiency regions corresping to column
- Low cost large production to be proven





THE PLANAR PIXEL UPGRADE



The ATLAS Planar Pixel Sensor R&D

- Aim: Explore the suitability of planar pixel sensors for highest fluences
- Approved ATLAS R&D project since 2009: 17 institutes, > 80 scientists

ATLAS	R&D on Planar Pixel Sensor Technology for the ATLAS Inner Detector Upgrade		
ATLAS Upgrade Document No:	Institute Document No.	Crested: 10/01/2008	Page 1 of 19
		Modified: 07/05/2009	Rev. No.: 1.1

IBL + Long Term (2017 or 2020)

D. Dobos, B. Di Girolamo, H.Pernegger, S. Roe, A. La Rosa¹, V. Vrba, P. Sicho, J. Popule, M.Tomasek, L. Tomasek, J. Stastny, M. Marcisovsky, M. Havranek, J. Bohm², A. Lounis, N. Dinu, M. Benoît, R. Tanaka³, G. Calderini, D. Lacour, H. Lebbolo, G. Marchiori, J. Ocariz, P. Schwemling⁴, M. Barbero, F. Hügging, H. Krüger, N. Wermes⁵, H. Lacker⁶, I. M. Gregor, U. Husemann, P. Kostka⁷, C. Gößling, R. Klingenberg, D. Münstermann, A. Rummler, G. Troska, T. Wittig, R. Wunstorf⁸, J. Grosse-Knetter, M. George, A. Quadt, J. Weingarten⁹, L. Andricek, M. Beimforde, A. Macchiolo, H.-G. Moser, R. Nisius, R. Richter, P. Weigell¹⁰, D. Cauz, M. Cobal, C. del Papa, D. Esseni, M. P. Giordani, P. Palestri, G. Pauletta, L. Selmi¹¹, Y. Unno, S. Terada, Y. Ikegami¹², M. Cavalli, I. Korolkov, M. Lozano, C. Padilla, G. Pellegrini, M. Ullan¹³, T. Affolder, P. Allport, G. Casse, T. Greenshaw, I. Tsurin¹⁴, M. Battaglia, T. Kim, S. Zalusky¹⁵, I. Gorelov, M. Hoeferkamp, S. Seidel, K. Toms¹⁶, V. Fadeyev, A. Grillo, J. Nielsen, H. Sadrozinski, B. Schumm, A. Seiden¹⁷

17 institutions:

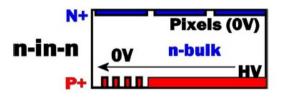
¹CERN, ²AS CR, Prague, ³LAL Orsay/ University Paris-sud XI, ⁴LPNHE / University Paris VI, ⁵University of Bonn, ⁶HU Berlin, ⁷DESY, ⁸TU Dortmund, ⁹University of Goettingen, ¹⁰MPP and HLL Munich, ¹¹Università degli Studi di Udine – INFN, ¹²KEK, ¹³IFAE-CNM (Barcelona), ¹⁴University of Liverpool, ¹⁵UC Berkeley/LBNL, ¹⁶UNM, Albuquerque, ¹⁷UCSC, Santa Cruz



Why planar sensors?



- Planar pixel is a proven technology
 - the current n-in-n pixel detector.
 - Modules shown to work after 10¹⁵ neq/cm2
 - If strips not adequate any more, pps would be the natural option
- Potential for a low-cost large-area production with n-in-p
 - Only one side is patterned
- Research directions
 - Radiation damage studies
 - Active area optimization and geometry redesign
 - Advanced simulation studies
 - High rate capable electronics
 - Low cost module production



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TCAD simulation



- Technology Computer Aided Design offers the possibility to simulate the behavior of a sensor under several conditions
 - Reverse bias
 - Illuminated by light
 - At high/low temperature
 - As been exposed to high fluences
- And monitor the interesting quantities
 - IV / CV curves
 - GR potentials
 - CCE
 - Electric field

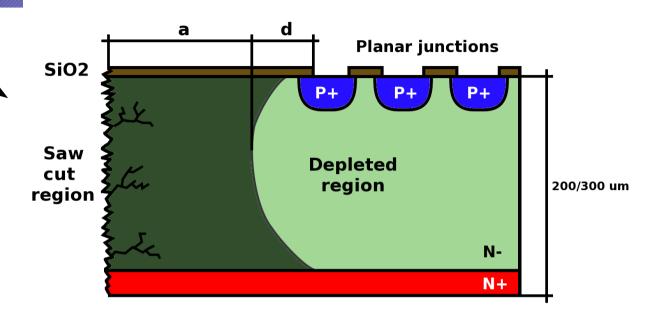
Simulation saves you money but needs very precise inputs to produce reliable information



Geometry - Dead edge



Dead edge is an inactive area whose porpouse is to protect the cut area (full of generation centers) from high electric field



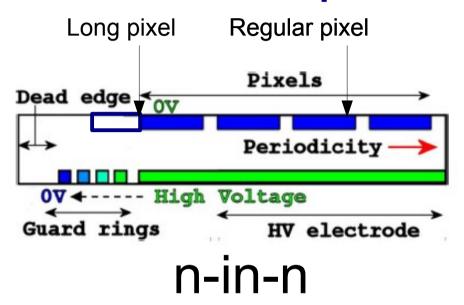
• "It is not possible to obtain the full geometrical coverage in z as the Pixel detector does, where modules are tilted in z and are partially overlapped, because there is not enough space. However the gap between modules is minimized using a sensor design with active or slim edges." IBL TDR

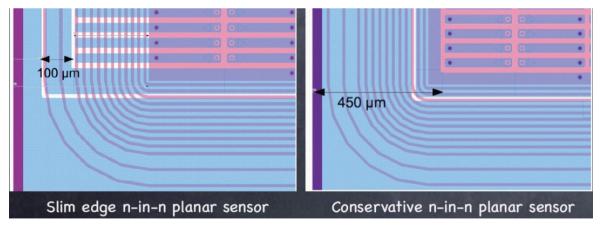


Geometry optimizations

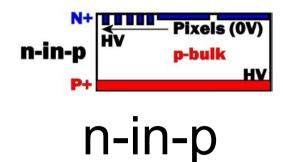


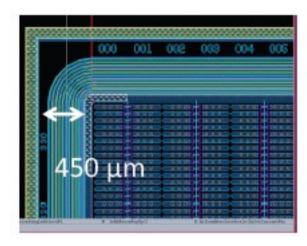
Attempt to recover active area





Longer pixel "under the guard-ring"





Reducing GRs structure width

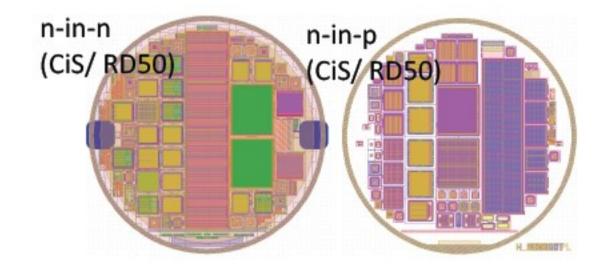
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First PPS sensor submission



 Based on an intense design and simulation work, a first submission of planar sensors was made

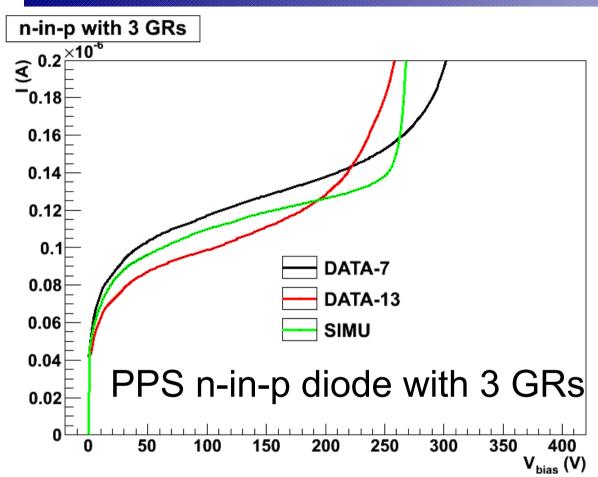


- Current ATLAS R.O.C. ("FE-I3") compatible sensors
- New ATLAS R.O.C. ("FE-I4") compatible sensors
- Diodes, test structures

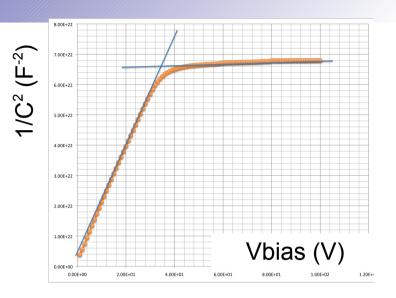


Test on prototypes





Tuning for bulk concentration and generation lifetime for simulation



Measures were taken in our clean room

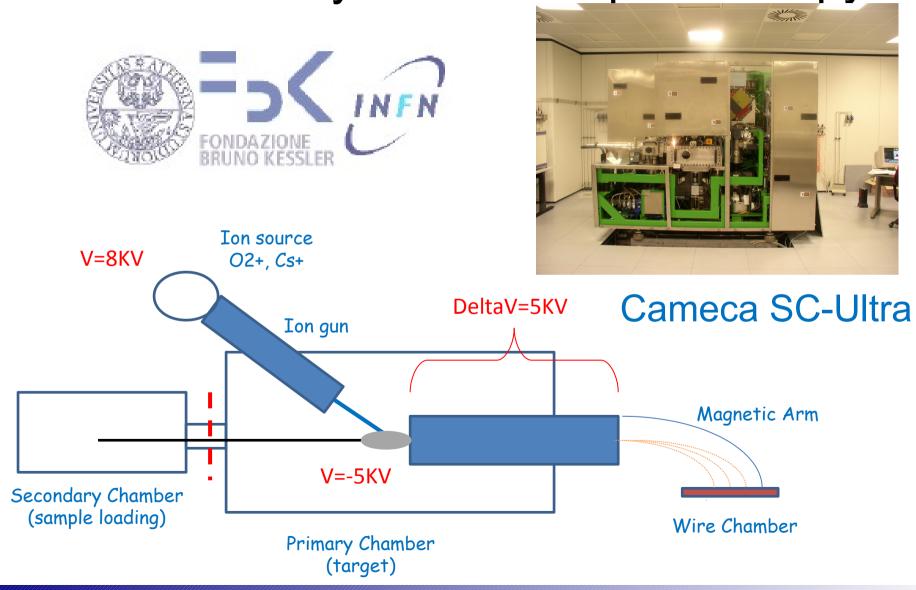




SIMS measurements



SIMS: Secondary Ion Mass Spectroscopy

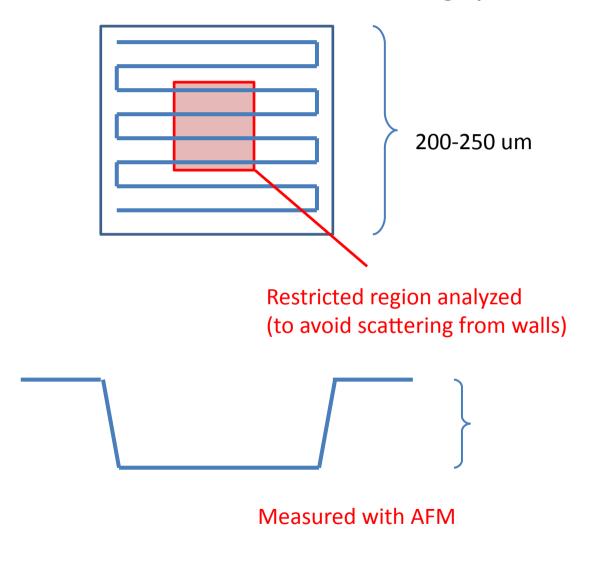


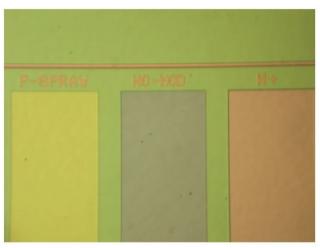


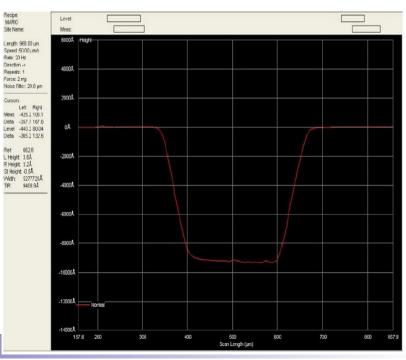
SIMS principle



An ion beam is scanning (and escavating the sample)



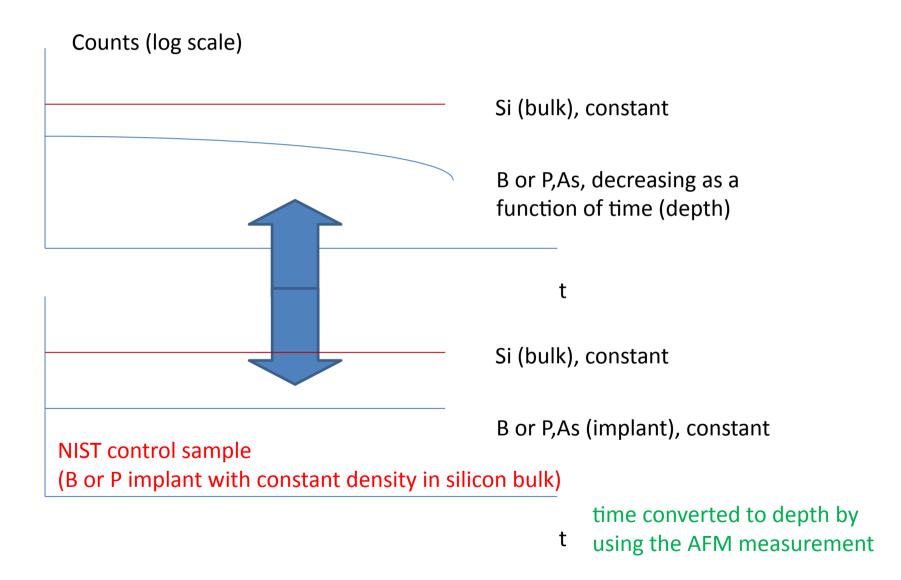






Doping profile measurement

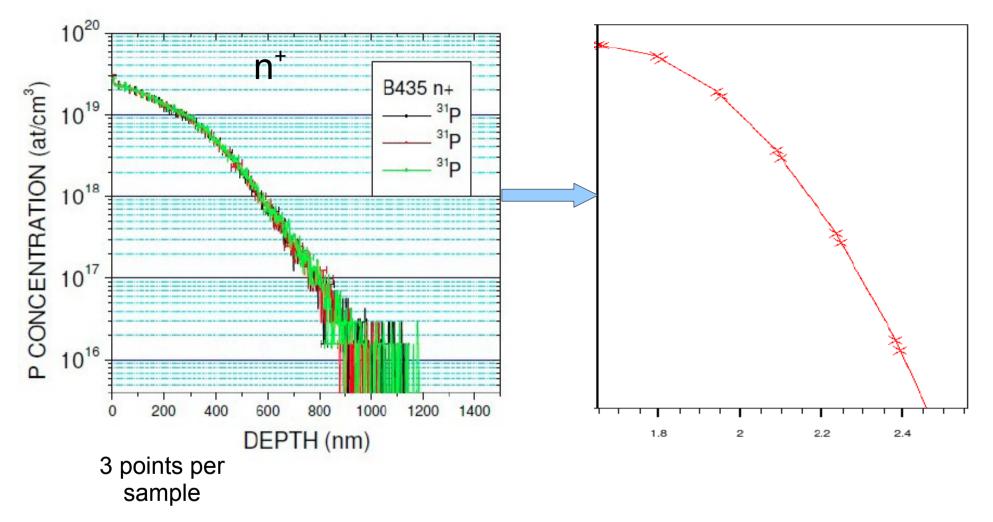






Example: pixel implant





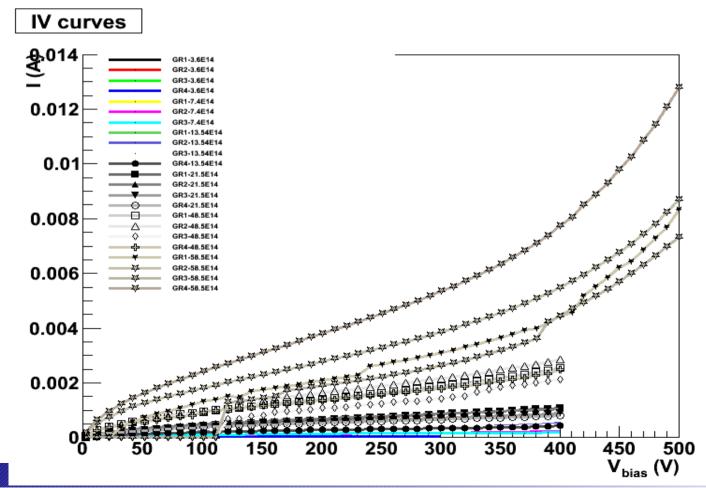
- Concentration profiles are used inputs for the simulation
 - Same for p+, moderate and non-moderate p-spray



Irradiation campaings



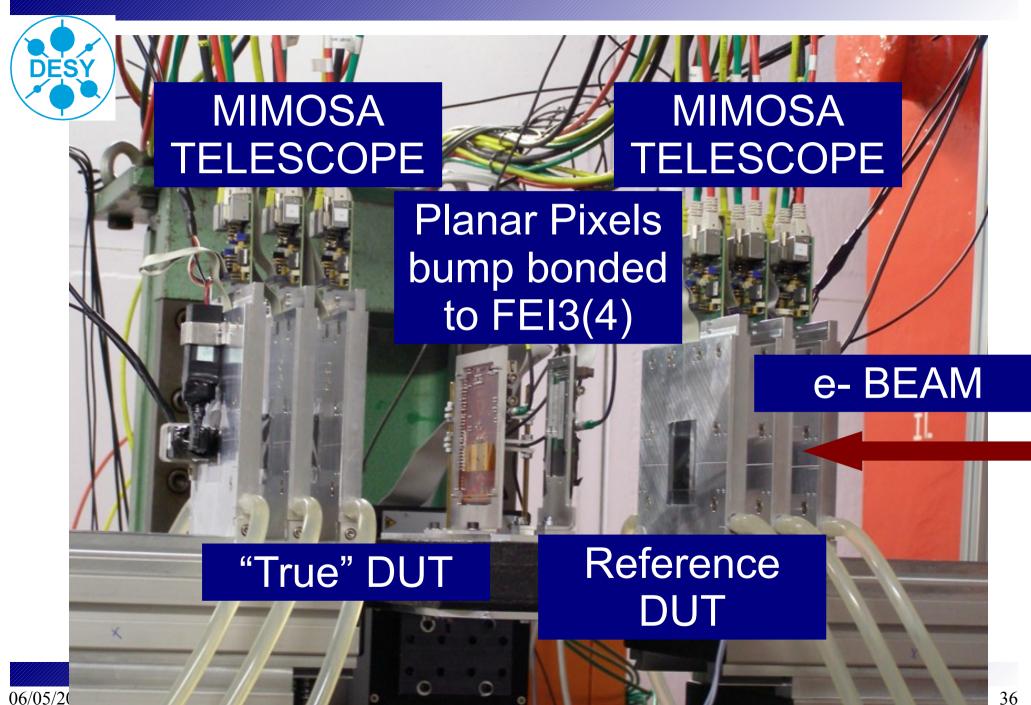
- 24 GeV/c proton at CERN (with step of fluence 2x10¹⁴ to 4x10¹⁵ n_{eq}/cm²)
- MeV neutrons irradiation in Ljubjiana (Up to 1x10¹⁶ n_{eq}/cm²)





Test beams



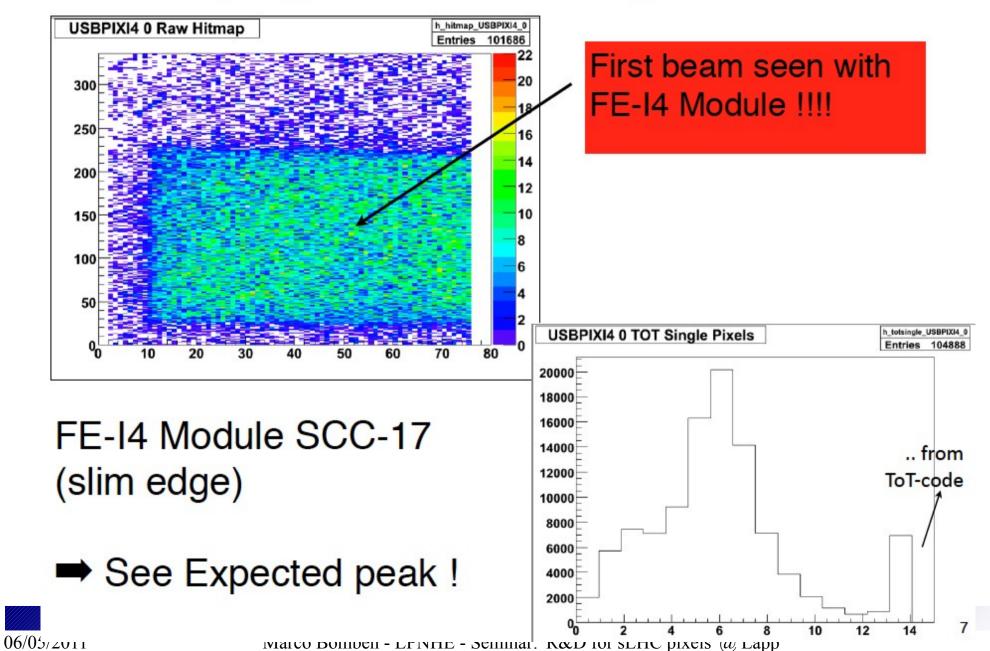




Pictures from a test beam



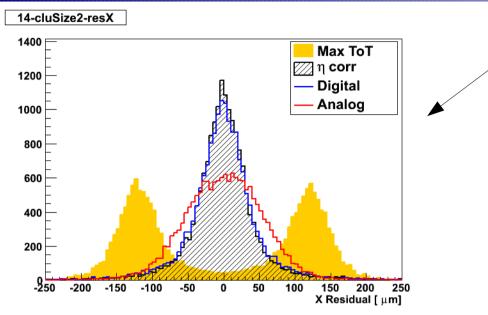






Test beam data analysis

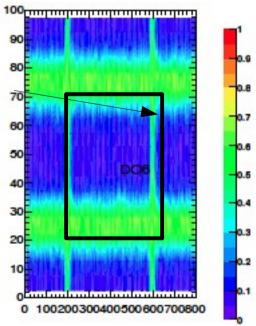




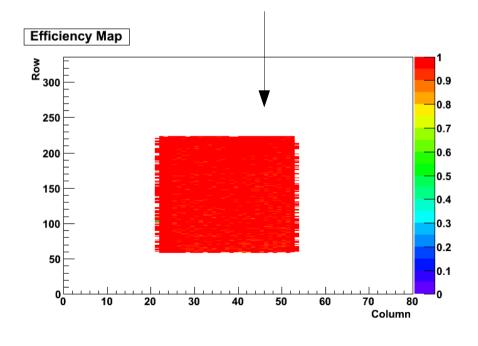
- Space point resolution

 Different cluster
 - Different clusteralgorithms are compared

 Charge sharing among pixel cells



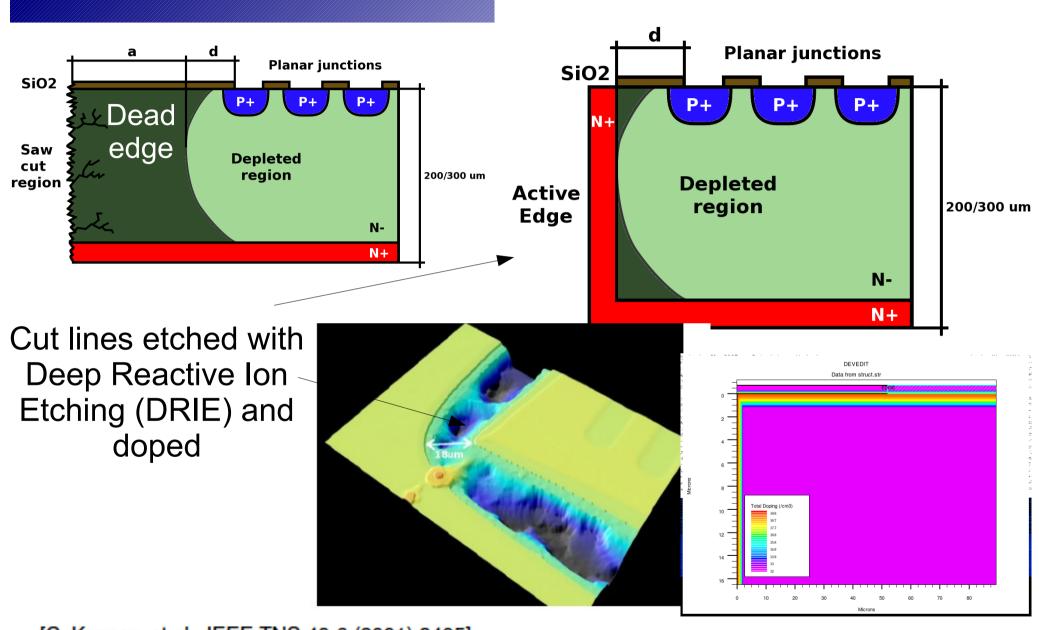
Efficiency





Ideas for new submission





[C. Kenney, et al., IEEE TNS 48-6 (2001) 2405]





CONCLUSIONS



Conclusion & Outlook



- LHC will turn into a High Luminosity machine after 2017
- A completely new detector is needed, coping with higher rates and large radiation fluence
- The PPSU R&D group is working on the new Pixel Tracker for ATLAS
- Key parameters for the new detector are
 - Radiation hardness
 - Low material budget and optimized geometry
 - Charge collection efficiency
- Detailed simulations, and measurements, performed at test beams, after irradiations and on test structures, are driving the new pixel design



That's it!

